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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of**

Noboru Ichinose, et al.

**Serial No.:** 10/567,369

**Group Art Unit:** 2814

**Filed:** May 15, 2006

**Examiner:** Sarah Kate Salerno

**For:** SEMICONDUCTOR LAYER WITH A  $\text{GA}_2\text{O}_3$  SYSTEM

Honorable Commissioner of Patents  
Alexandria, VA 22313 – 1450

**STATEMENT OF SUBSTANCE OF THE INTERVIEW**

Sir:

Applicants thank the Examiner for the Personal Interview of October 7, 2010.

The Examiner agreed that the Amendment and verified translation of the priority document that were filed on September 30, 2010 overcome the prior art of record. The Examiner indicated that she would reconsider her position in the next office communication.

Respectfully Submitted,

Date: 10/13/10

Farhad Shir, Ph.D.  
Registration No. 59,403

Sean M. McGinn, Esq.  
Registration No. 34,386

**MCGINN INTELLECTUAL PROPERTY  
LAW GROUP, PLLC**

8321 Old Courthouse Road, Suite 200  
Vienna, Virginia 22182-3817  
(703) 761-4100  
Customer No. 21254